## CURRICULUM VITAE

NAME	Zsolt Czigány	
ADDRESS	HUN-REN; Center for Energy Research Institute for Technical Physics and Materials Science Konkoly-Thege Miklós út 29-33, H-1121 Budapest, Hungary Phone: +36-1-3922222/1755 E-mail: czigany.zsolt@ek.hun-ren.hu	
BORN	1968 Hungary	
LANGUAGES	English, Swedish – advanced Russian - intermediate	
SCIENTIFIC DEGREES	<ul> <li>1992 M.Sc.</li> <li>1999 Ph.D.</li> <li>2002 docent</li> <li>2013 DSc</li> </ul>	Roland Eötvös University, Budapest, Hungary Roland Eötvös University, Budapest, Hungary Linköping University, Linköping, Sweden Hungarian Academy of Sciences
PRESENT POSITION	Scientific Advisor at Thin Film Physics Department	
RESEARCH ACTIVITIES	Structure and morphology of multilayers/superlattices (Ag/Cu, Si/Ge, MgF <sub>2</sub> /LaF <sub>3</sub> ) Fullerene-like structure in thin films (C, $CN_x$ and $CP_x$ , $MoS_2$ , $WS_2$ ) Hard materials: WC, MAX-phases, ScAlN, TiAlN, VAIN solid solutions and phases Wide band gap semiconductors and conductive oxides (sp <sup>2</sup> -BN, SiC, ZnO) apatites; X <sub>2</sub> BC (X=W, Mo,Ta, Nb, Hf) hard coatings.	
VISITS and POSITIONS ABROAD	1995Thin Film C1996Fraunhofer	Group at Linköping University, Sweden (3 weeks) Group at Linköping University, Sweden (4 weeks) Institut, Jena, Germany (4 months) Group at Linköping University, Sweden (3 years)
AWARDS	Award of the Hungarian Society of Electron Microscopy; 2003 Outstanding Paper Award of European Microscopy Society; Materials Sciences 2010 Schmid Rezső Prize of Roland Eötvös Physical Society; 2011 Pócza Jenő Prize of the Hungarian Society of Electron Microscopy; 2011 Bolyai János Research Scholarship (Hungarian Academy of Sciences); 2011	
EXPERIENCE	Transmission electron microscopy (TEM) and sample preparation Structure and SAED of amorphous and nanostructured materials Thin film deposition (evaporation, sputtering)	
AFFILIATIONS	Member of the Hungarian and European Microscopy Society Member of the Roland Eötvös Physical Society and European Physical Society Board member of vacuum science and technology division Member of the Hungarian and EuropeanVacuum Society Editorial Board member of Applied Microscopy	
PUBLICATIONS	127 reviewed papers; $\Sigma$ IF = 370; more than 3300 citations; Hirsch index =32	